

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Neo C. Peng et al.

Title: WAFER DICING DEVICE AND METHOD

Docket No.: 303.772US2

Serial No.: 10/823,314

Filed: April 13, 2004

Due Date: June 29, 2007

Examiner: Samuel M Heinrich

Group Art Unit: 1725

**MS Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

X Response to Restriction Requirement (10 pgs.).

If not provided for in a separate paper filed herewith, Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

By: 

Atty: Timothy B. Clise

Reg. No. 40,957

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 28 day of June, 2007.

Kate Cannon  
Name

Kate Cannon  
Signature

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

(GENERAL)